

saes
group

SAES Pure Gas

The Technology of Pure Gas

AMBIENT INLINE PURIFIER 202 PURIFICATION MEDIA SPECIFICATION



0 – 2,000 slpm Ambient Inline Purifiers.
For consistent gas quality and
Impurity removal to pptV levels.

MicroTorr Ambient Inline Purifiers:

MicroTorr purifiers are the most complete and reliable solution for Point-of-Use (POU) gas purification. Combining model size with a selection of gas-specific purification materials, MicroTorr purifiers can be tailored to many different customer applications, while maintaining impurity removal to Part-Per-Billion (ppbV) levels or better. Optional valves and a 0.003 micron particle filter are available as well as custom subsystem configurations.

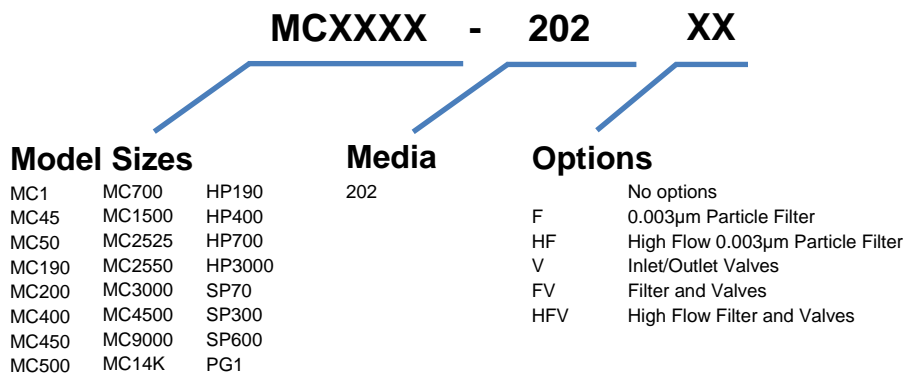
Competitive Advantages and Benefits:

- **Reliability:** Uncompromised process consistency and yield improvement.
- **Performance:** State-of-the-art purification technology, low pressure drop, and long lifetimes.
- **Regenerability:** Most MicroTorr media are factory regenerable, minimizing potentially hazardous waste.
- **Quality:** 316L stainless steel, Helium leak checked, and analytical testing to part-per-trillion (pptv) levels.
- **Support:** Lifetime estimation and regeneration service available through SAES Pure Gas Sales Network.

202 Media Purifier Properties

Gases Purified	CDA, O2, N2, Ar, He, Kr, Ne, Xe, H2, D2, CO2, N2O, NO, CF4
Impurities Removed	H₂O < 1 ppbV
Particle Filtration	2 micron or 0.003 micron metal
Vessel construction	Stainless Steel 316L, electropolished to 10 Ra
Installation Orientation	Vertically with flow downward. Consult factory for other orientations.
Leak Rating	1 x 10 ⁻⁹ atm cc/sec of He
Operating temperature	-20 to 65 °C (-4 to 149°F) Lifetime may be effected at higher temperatures
Lifetime	Contact SAES Pure Gas for application specific lifetime calculations
Regenerability	Regenerable at SAES Pure Gas Regeneration Centers
Certification	CE Certified to the Pressure Equipment Directive (PED) Designed in accordance with ASME

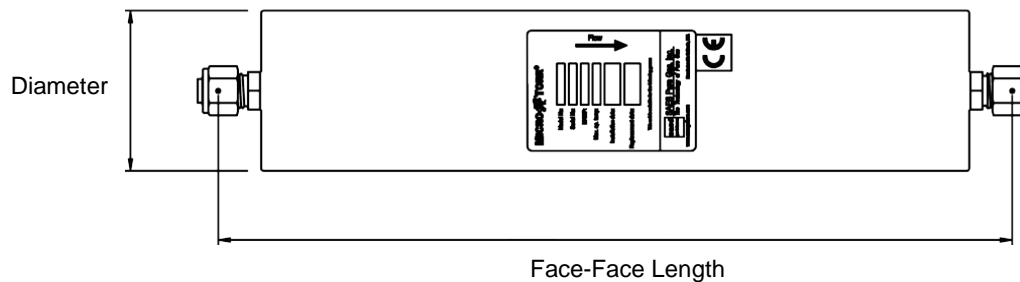
Part Number Configuration:



Purifier Sizes

Part Number	Maximum Flow (slpm)	Average Flow (slpm)	Operating Pressure (psig) Must be in gas phase	Inlet Connection	Outlet Connection	Diameter (inches [mm])	Face to Face Length (inches [mm])	Weight (lb. [kg])
Standard Models								
MC1-202F	5	0.5	1,000	1/4" MVCR	1/4" MVCR	1.5 [38.1]	3.31 [84.1]	< 0.7 [0.3]
MC45-202 MC45-202F	10	1.5	1,000	1/4" MVCR	1/4" MVCR	1.5 [38.1]	4.50 [114.3]	< 0.9 [0.4]
MC50-202F	10	1.5	1,000	1/4" MVCR	1/4" MVCR	1.5 [38.1]	5.00 [127.0]	< 0.9 [0.4]
MC190-202F	50	5	250	1/4" MVCR	1/4" MVCR	2.0 [50.8]	8.20 [208.3]	< 1.6 [0.7]
MC200-202F	50	5	250	1/4" MVCR	1/4" MVCR	2.0 [50.8]	6.30 [160.0]	< 1.8 [0.8]
MC400-202F	60	9	250	1/4" MVCR	1/4" MVCR	3.0 [76.2]	8.20 [208.3]	< 4.9 [2.2]
MC450-202F	75	10	250	1/4" MVCR	1/4" MVCR	3.0 [76.2]	7.94 [201.7]	< 4.1 [1.8]
MC500-202F	100	12	250	1/4" MVCR	1/4" MVCR	2.0 [50.8]	12.50 [317.5]	< 2.8 [1.2]
MC700-202F	120	25	250	1/4" MVCR	1/4" MVCR	3.0 [76.2]	10.00 [254.0]	< 7.6 [3.4]
MC1500-202F	250	40	250	1/2" MVCR	1/2" MVCR	3.0 [76.2]	18.20 [462.3]	< 8.0 [3.6]
MC2525-202F	300	80	250	1/4" MVCR	1/4" MVCR	4.0 [101.6]	17.30 [439.0]	< 13.0 [5.9]
MC2550-202F	500	80	250	1/2" MVCR	1/2" MVCR	4.0 [101.6]	17.60 [447.0]	< 13.0 [5.9]
MC3000-202 MC3000-202F	500	80	250	1/2" MVCR	1/2" MVCR	4.0 [101.6]	20.00 [508.0]	< 14.0 [6.4]
MC4500-202F	500	200	250	1/2" MVCR	1/2" MVCR	6.0 [152.4]	27.64 [702.6]	< 43.0 [19.5]
MC4500-202 MC4500-202HF	1,000	200	250	1/2" MVCR	1/2" MVCR	6.0 [152.4]	27.64 [702.6]	< 43.0 [19.5]
MC9000-202 MC9000-202F	1,000	300	250	1/2" MVCR	1/2" MVCR	6.0 [152.4]	39.34 [999.7]	< 60.4 [27.4]
MC14K-202F	2,000	400	250	3/4" MVCR	3/4" MVCR	6.0 [152.4]	50.80 [1290.0]	< 82.0 [37.2]
High Pressure Models								
HP190-202F	50	5	1,000	1/4" MVCR	1/4" MVCR	2.0 [50.8]	8.20 [208.3]	< 2.1 [0.9]
HP400-202F	60	9	1,000	1/4" MVCR	1/4" MVCR	3.0 [76.2]	8.20 [208.3]	< 4.9 [2.2]
HP700-202F	120	25	1,000	1/4" MVCR	1/4" MVCR	3.0 [76.2]	10.0 [254.0]	< 7.6 [3.4]
HP3000-202F	500	80	1,000	1/2" MVCR	1/2" MVCR	3.9 [100.1]	20.0 [508.0]	< 26.0 [11.8]
SP70-202F	20 (<2,000 psig) 40 (>2,000 psig)	1.5	3,000	1/4" MVCR	1/4" MVCR	2.0 [50.8]	5.00 [127.0]	< 2.3 [1.0]
SP300-202F	100 (<2,000 psig) 200 (>2,000 psig)	10	3,000	1/4" MVCR	1/4" MVCR	2.0 [50.8]	15.00 [381.0]	< 6.6 [3.0]
SP600-202F	200 (<2,000 psig) 400 (>2,000 psig)	15	3,000	1/4" MVCR	1/4" MVCR	2.0 [50.8]	25.00 [635.0]	< 11.0 [5.0]

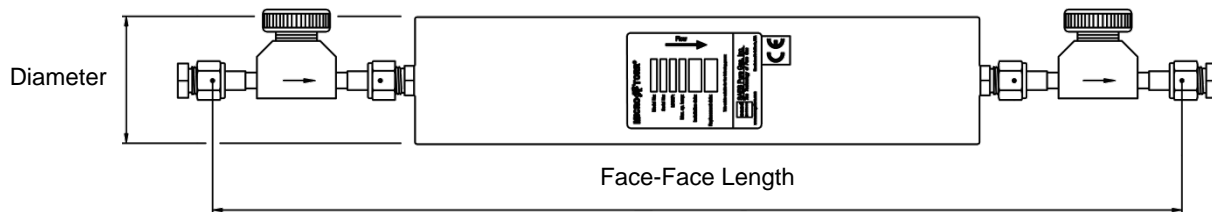
F = 0.003 micron particle filter



Purifier Sizes, with inlet and outlet isolation valves

Part Number	Maximum Flow (slpm)	Average Flow (slpm)	Operating Pressure (psig) Must be in gas phase	Inlet Connection	Outlet Connection	Diameter (inches [mm])	Face to Face Length with valves (inches [mm])	Weight with valves (lb. [kg])
Standard Models								
MC1-202FV	5	0.5	1,000	1/4" FVCR	1/4" FVCR	1.5 [38.1]	8.91 [226.3]	< 2.6 [1.2]
MC45-202V MC45-202FV	10	1.5	1,000	1/4" FVCR	1/4" FVCR	1.5 [38.1]	10.10 [256.5]	< 2.9 [1.3]
MC50-202FV	10	1.5	1,000	1/4" FVCR	1/4" FVCR	1.5 [38.1]	10.60 [269.2]	< 2.9 [1.3]
MC190-202FV	50	5	250	1/4" FVCR	1/4" FVCR	2.0 [50.8]	13.80 [350.5]	< 3.7 [1.7]
MC200-202FV	50	5	250	1/4" FVCR	1/4" FVCR	2.0 [50.8]	11.90 [302.3]	< 3.8 [1.8]
MC400-202FV	60	9	250	1/4" FVCR	1/4" FVCR	3.0 [76.2]	13.80 [350.5]	< 6.8 [3.1]
MC450-202FV	75	10	250	1/4" FVCR	1/4" FVCR	3.0 [76.2]	13.54 [343.9]	< 6.0 [2.7]
MC500-202FV	100	12	250	1/4" FVCR	1/4" FVCR	2.0 [50.8]	18.10 [459.7]	< 4.5 [2.0]
MC700-202FV	120	25	250	1/4" FVCR	1/4" FVCR	3.0 [76.2]	15.60 [396.2]	< 9.6 [4.4]
MC1500-202FV	250	40	250	1/2" FVCR	1/2" FVCR	3.0 [76.2]	28.84 [732.5]	< 12.5 [5.8]
MC2525-202FV	300	80	250	1/4" FVCR	1/4" FVCR	4.0 [101.6]	23.20 [589.0]	< 15.0 [6.8]
MC2550-202FV	500	80	250	1/2" FVCR	1/2" FVCR	4.0 [101.6]	28.20 [716.0]	< 17.7 [8.0]
MC3000-202V MC3000-202FV	500	80	250	1/2" FVCR	1/2" FVCR	4.0 [101.6]	30.64 [778.3]	< 18.7 [8.5]
MC4500-202FV	500	200	250	1/2" FVCR	1/2" MVCR	6.0 [152.4]	38.30 [972.8]	< 48.7 [22.1]
MC4500-202V MC4500-202HFV	1,000	200	250	1/2 FVCR	1/2 MVCR	6.0 [152.4]	38.30 [972.8]	< 48.7 [22.1]
MC9000-202V MC9000-202FV	1,000	300	250	1/2" FVCR	1/2" MVCR	6.0 [152.4]	50.00 [1270.0]	< 66.0 [29.9]
MC14K-202FV	2,000	400	250	3/4" FVCR	3/4" MVCR	6.0 [152.4]	67.10 [1705.0]	< 88.0 [39.9]
High Pressure Models								
HP190-202FV	50	5	1,000	1/4" FVCR	1/4" FVCR	2.0 [50.8]	13.80 [350.5]	< 4.1 [1.8]
HP400-202FV	60	9	1,000	1/4" FVCR	1/4" FVCR	3.0 [76.2]	13.80 [350.5]	< 6.8 [3.1]
HP700-202FV	120	25	1,000	1/4" FVCR	1/4" FVCR	3.0 [50.8]	15.60 [396.2]	< 9.6 [4.4]
HP3000-202FV	500	80	1,000	1/2" FVCR	1/2" FVCR	3.9 [100.1]	28.90 [756.0]	< 30.7 [13.9]
SP70-202FV	20 (<2,000 psig) 40 (>2,000 psig)	1.5	3,000	1/4" FVCR	1/4" FVCR	2.0 [50.8]	10.60 [270.0]	< 4.3 [1.9]
SP300-202FV	100 (<2,000 psig) 200 (>2,000 psig)	10	3,000	1/4" FVCR	1/4" FVCR	2.0 [50.8]	20.60 [524.0]	< 8.6 [3.9]
SP600-202FV	200 (<2,000 psig) 400 (>2,000 psig)	15	3,000	1/4" FVCR	1/4" FVCR	2.0 [50.8]	30.60 [778.0]	< 13.0 [13.9]
"U" Shaped Manifold								
PG1-202FV	15	10	250	1/4" FVCR	1/4" MVCR	2.0 [50.8]	13.80 [350.5]	< 5.1 [2.3]

F = 0.003 micron particle filter
V = inlet and outlet isolation valves



Bypass and Dual Purifier Manifold Assemblies:

Many configurations are available; please consult the factory for details.

Other Purification Media's Available:

Media	Gases Purified	Impurities Removed
202 Covered by this Specification	CDA, O2, N2, Ar, He, Kr, Ne, Xe, H2, D2, CO2, N2O, NO, CF4	H2O to < 1 ppb
203	CDA, O2, N2, Ar, He, Kr, Ne, Xe, H2, D2, N2O, NO, CF4	H2O, CO2 to < 100 ppt; Volatile Acids, Organics, Refractory Compounds to < 1 ppt; Volatile Bases < 5 ppt, Metals < 1 ppb
302	HCl, Cl2, B2H6, BCl3, CClH3, GeCl4, GeH4, H2S, H2Se, HBr, NF3, SiCl4, SiF4, SiH2Cl2, SiHCl3, SO2, CHClF2, BF3,	H2O to < 1 ppb; Metals < 1 ppb
403	N2, Ar, He, Kr, Ne, Xe, H2, CDA, O2	Volatile Acids, Organics, Refractory Compounds to < 1 ppt; Volatile Bases < 5 ppt, Metals < 1 ppb
404	N2, Ar, He, Kr, Ne, Xe, H2, CDA, O2, CO2, C2H2, C3H6, C2H4, NH3, C2H6, C3H8, C4H10	Organics < 1 pptV, Metals < 1 ppbV
502	AsH3, PH3	H2O, O2 to < 1 ppb, Metals < 1 ppbV
503	H2 with up to 1% O2; O2 with up to 2% H2	H2 in O2 or O2 in H2 < 1 ppmV
602	CO	H2O, O2, CO2, Acids, Bases, Organics, Refractory Compounds, Metals < 1 ppbV
702	NH3, C2H7N, C2H8N2, C2H4, C3H6, CH3SiH3, GeH4, SF6, SiH4, H2/SiH4 mixtures	H2O, O2, CO2, NMHCs, Metals to < 1 ppb
802	SiH4	H2O, O2, CO, CO2, NMHCs, Sulphur compounds, Metals removal < 1 ppb
804	CO2	H2O, O2, CO, H2 to < 100 ppt; Volatile Acids, Organics, Refractory Compounds to < 1 ppt; Volatile Bases < 5 ppt, Metals < 1 ppbV
805	CO2	H2O < 100 ppt; Volatile Acids, Organics, Refractory Compounds to < 1 ppt; Volatile Bases < 5 ppt, Metals < 1 ppbV
902	N2, Ar, He, Kr, Ne, Xe, CH4, C2H6, C3H8, C4H10, SF6, Fluorocarbons	H2O, O2, CO, CO2, H2 to < 100 ppt; Volatile Acids, Organics, Refractory Compounds to < 1 ppt; Volatile Bases < 5 ppt, Metals < 1 ppbV
904	H2, D2, H2-Inerts Mix	H2O, O2, CO, CO2 to < 100 ppt; Volatile Acids, Organics, Refractory Compounds to < 1 ppt; Volatile Bases < 5 ppt, Metals < 1 ppbV
906	CDA, O2, N2O	H2O, CO, CO2, NMHC to < 1 ppb, Metals < 1 ppbV

Purifier Regeneration:

Available from any SAES Pure Gas Regeneration Center.



CE Directive:

All MicroTorr Purifiers meet CE directive requirements and come with the CE Marking.

